

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			Attorney Docket No.: 18564-003000US Applicant: Nathan S. Lewis, et al. Filing Date: Herewith		Application No.: Unassigned Group: Unassigned	
Reference Designation			U.S. PATENT DOCUMENTS			
Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
<u>DKM</u> AA	4,871,680	10/03/89	Barraud <i>et al.</i>	436	103	
<u>I</u> AB	5,334,351	08/02/94	Heinze <i>et al.</i>	422	90	
<u>I</u> AC	5,417,100	05/23/95	Miller <i>et al.</i>	73	31.02	
<u>DKM</u> AD	5,512,882	04/30/96	Stetter <i>et al.</i>	340	632	
AE						
AF						
AG						
AH						
AI						
AJ						
AK						
AL						
FOREIGN PATENT DOCUMENTS						
	Document No.	Date	Country	Class	Sub-class	Translation (Yes/No)
<u>DKM</u> AM	WO 9607901	03/14/96	PCT	G01N	33/00	
<u>I</u> AN	EP 0161987	11/21/85	Europe (Abstract)	C07C	121/66	
<u>I</u> AO	DE 3305683	08/23/84	Germany (Abstract)	G01N	27/12	
<u>I</u> AP	DE 19509518	09/26/96	Germany (Abstract)	G01N	33/00	
<u>I</u> AQ	DE 4241438	01/05/94	Germany	G01N	27/30	No
<u>DKM</u> AR	EP 0251934	01/07/88	Europe	G01N	27/12	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
<u>DKM</u> AS	Lonergan, M.C., <i>et al.</i> , "Array-Based Vapor Sensing Using Chemically Sensitive, Polymer Composite Resistors" IEEE Aerospace Conference. 3:583-631 (1997)					
<u>DKM</u> AT	Lonergan, M.C., <i>et al.</i> , "Array-Based Vapor Sensing Using Chemically Sensitive, Carbon Black-Polymer Resistors" Chem. Mater. 8(9):2298-2312 (1996)					
AU						
AV						
AW						
EXAMINER	<u>Wayne H. Harty</u>		DATE CONSIDERED		<u>8/3/05</u>	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.